



#12/IDS
And
10/24/00

- 1 -

Docket: 0756-1984

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)

Shunpei Yamazaki)

Serial No. 09/334,646)

Filed: June 17, 1999)

For: SEMICONDUCTOR DEVICE)

AND FABRICATION METHOD)

THEREFOR)

RECEIVED

OCT 19 2000

) Art Unit: 2811
) Examiner: S. HU TECHNOLOGY CENTER 2800

INFORMATION DISCLOSURE STATEMENT CERTIFICATE OF MAILING

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

I hereby certify that this
correspondence is being deposited with
the United States Postal Service with
sufficient postage as First Class Mail in
an envelope addressed to: Assistant
Commissioner for Patents, Washington,
D.C. 20231, on 10-4-00

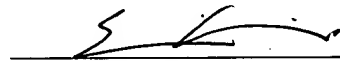
In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Statement, specifically, in an Office Action from the Korean Patent Office dated July 31, 2000. Inasmuch these references are being submitted within three months of the date of the aforementioned Office Action, it is believed that no fee is required.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,



Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110

EJR/wks

F:\DATA\wp2\WENDY\756-RESP\1984 IDS.wpd